

Application No.: 10/721,605
Attorney Docket: MXIC 1516-1

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On March 23, 2004.

Signed: Paul J. Dauenhauer

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Chih-Hao Wang et al.	
Application No.: 10/721,605	Attorney Docket No.: MXIC1516-1
Filed: 25 November 2003	Examiner: Unassigned
Title: Method for Forming Oxide on Ono Structure	Group: 2811
	Confirmation No.: 5625
	Customer No. 22470

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is requested that the information identified in this statement be considered by the Examiner and made of record in the above-identified application. This statement is not intended to represent that a search has been made or that the information cited in the statement is, or is considered to be, material to patentability as defined in 37 C.F.R. 1.56.

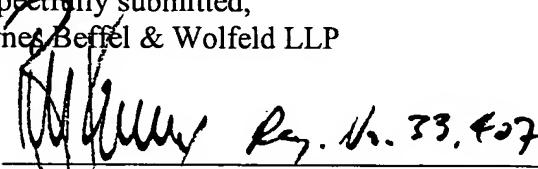
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Also enclosed with this statement is a copy of each cited document as required by 37 C.F.R. 1.98. However, since this application was filed after June 30, 2003, copies of U. S. Patents and U. S. Patent Application Publications are not enclosed. (See O. G. Notice of August 5, 2003.)

This statement should be considered under 37 C.F.R. 1.97(b) because it is being filed before the mailing date of the first Office Action on the merits.

Fee Authorization. The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 50-0869 (MXIC 1516-1). A duplicate copy of this authorization is enclosed.

Respectfully submitted,
Haynes Beffel & Wolfeld LLP

Date: 23 March 204
By: 
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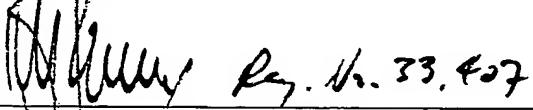
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(use as many sheets as necessary)

Sheet

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of

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Complete if Known

Application Number	10/721,605
Filing Date	11/25/2003
First Named Inventor	Chih-Hao Wang
Group Art Unit	2811
Examiner Name	Unassigned

Attorney Docket Number MXIC 1516-1

U.S. PATENT DOCUMENTS

Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
A1	4,949,154			Haken	08-14-1990	
A2	5,768,192			Eitan	06-16-1998	
A3	5,966,603			Eitan	10-12-1999	
A4	6,037,273			Gronet et al.	03-14-2000	
A5	6,074,917			Chang et al.	06-13-2000	
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A7	6,171,911			Yu	01-09-2001	
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A9						
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FOREIGN PATENT DOCUMENTS

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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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